



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q86579

Takanori MIYASAKA, et al.

Appln. No.: 10/526,031

Group Art Unit: 2856

Confirmation No.: 4777

Examiner: Unknown

Filed: February 28, 2005

For: MACHINERY FACILITY CONDITION MONITORING METHOD AND SYSTEM  
AND ABNORMALITY DIAGNOSIS SYSTEM

**SUBMISSION OF DRAWINGS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Submitted herewith please find fifty -one (51) sheets of drawings in compliance with  
37 C.F.R. § 1.84. The Examiner is respectfully requested to acknowledge receipt of these  
drawings.

Respectfully submitted,

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Date: September 27, 2005